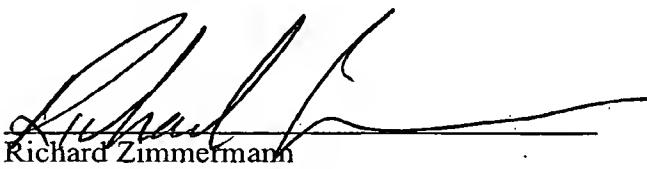


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Applicants: Scheuten et al. ) "EXPRESS MAIL" mailing label No.  
Serial No.: To be assigned ) EV686094936US.  
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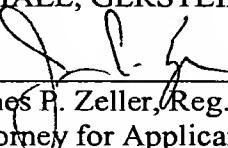
The documents listed on the enclosed Form PTO-1449 are identified pursuant to 37 CFR §§ 1.56, 1.97, and 1.98. Copies of the documents are enclosed as required.

JAP20 Rec'd PCT/PTO 03 APR 2006

Entry and consideration of the submitted documents are solicited.

Respectfully submitted,

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April 3, 2006

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Sheet 1 of 1

Form PTO-1449 (Modified)		U.S. Department of Commerce Patent and Trademark Office		Atty. Docket No. 30882/40950	Serial No. <b>10574633</b>
				Applicant Scheutens et al.	
				Filing Date September 22, 2004	Group

**U.S. PATENT DOCUMENTS**

*Examiner Initials	Document Number	Issue Date	Name	Class	Subclass	Filing Date if Appropriate
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	3,998,659	12/21/76	Wakefield	136	89 R	
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	5,567,469	10/22/96	Wada et al.	427	74	
	5,578,503	11/26/96	Karg et al.	437	5	

**FOREIGN PATENT DOCUMENTS**

*Examiner Initials	Document Number	Publication Date	Country	Class	Subclass	Translation	
						Yes	No
	940 860 A1	09/08/99	EPO				
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**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)**

	"Thin-Film CIS Alloy PV Materials Fabricated Using Non-Vacuum, Particles-Based Techniques", Eberspacher et al., Thin Solid Films 387, 2001, pp. 18-22
	International Search Report in PCT/EP2004/010615 dated March 31, 2005

Examiner /Miriam Berdichevsky/	Date Considered 07/07/2008
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.